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## A new comparison between solid-state therm ionics and therm oelectrics

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## Abstract

It is shown that the equations for electrical current in solid-state therm ionic and therm oelectric devices converge for devices with a width equal to the mean free path of electrons, yielding a common expression for intensive electronic e ciency in the two types of devices. This result is used to demonstrate that the materials parameters for therm ionic and therm oelectric refrigerators are equal, rather than di ering by a multiplicative factor as previously thought.

Solid-state them ionic devices may be distinguished from them oelectric devices according to whether electron transport is ballistic or di usive [1]. There is, however, little to distinguish the underlying them odynam ics of the two types of devices, with both achieving reversibility under the same conditions [2, 3], and both being governed by the same  $\ln a$ terials parameter' [4, 5, 6]. In previous work, a proportionality factor of  $F_0=F_{1=2}^{p}$  where  $F_n$  is a Ferm i integral, was found between the two materials parameters [5]. Here we show that the equations for di usive and ballistic transport converge for devices with a width equal to the mean-free path of electrons. This results in a common equation for intensive electronic e ciency for both therm ionic and therm oelectric devices, and a proportionality factor between their material parameters equal to unity. We explain the discrepancy between this and previous work by pointing out an inconsistency in the energy dependency of the relaxation time in two equations for conductivity used in [5].

Current in both therm ionic and therm oelectric devices can be expressed as

$$J = j(k) dk$$
(1)

where j(k) k is the net 'energy-resolved' current of electrons owing in the direction opposite to the temperature gradient with momentum in the range k around k. In therm ionic devices with a width less than the mean-free-path, most electrons travel ballistically from one reservoir to another. In this case the energy resolved current density is given by (with dependence upon k implicit)

$$j^{b}(\mathbf{k}) \mathbf{k} = q \mathbf{D}_{r} \mathbf{v}_{\mathbf{x}} \mathbf{f}_{0} \mathbf{k}$$
(2)

where  $D_r(k)$  is the density of states (DOS) in the reservoirs, (k) is the probability that electrons are transmitted between the reservoirs,  $v_x(k)$  is the velocity in the direction of transport, and  $f_0 = [f_0(k; _C; T_C) - f_0(k; _H; T_H)]$  is the dimension of the Fermi occupation of states in the cold/hot reservoirs where

$$f_0 (k;;T) = 1 + \exp \frac{E(k)}{kT}^1$$
. (3)

and where  $_{C=H}$  is the electrochem ical potential and  $T_{C=H}$  the tem perature of electrons at the hot/cold ends of the device.

Here we follow previous work [5], and assume the transmission probability depends upon the total momentum of electrons rather than momentum in the direction of transport only, allowing a direct comparison with them oelectrics in which the energy of mobile electrons is also restricted in all three dimensions (this assumption is made implicitly in [5], between Eq. 1.1 and Eq. 1.3). The theoretical dimensions between thermionic devices in which the transmission probability is a function of k and  $k_x$  are explored in detail in other papers [7, 8, 9].

In them oelectric devices the energy-resolved di usive electron current density m ay be obtained from the Boltzm ann transport equation under the relaxation time approximation, and can be written as [10]

$$j^{d}$$
 (k)  $k = qD_{1} v_{x}^{2} \frac{df_{0}}{dx} k$  (4)

where  $D_1(k)$  is the local DOS,  $(k) = {}_0E(k)^r$  is the relaxation time in the direction of transport.

In solid-state power generators and refrigerators with a width close to the electronic meanfree-path it is expected that equations 2 and 4 should yield the same results. To show this, we take the energy dependence of the relaxation time to be r = 1=2, which corresponds to scattering that is dominated by acoustic phonons, and results in a mean-free-path in the direction of transport,  $v_x(k)(k)$ , which is independent of energy [5]. We also note that  $df_0(x) = dx$  [ $f_0(x)$   $f_0(x + x)$ ] = x when x is small, so that, for a piece of therm oelectric material L = in length,  $df_0(x) = dx$   $f_0 =$ , and equation 4 becomes

$$j^{a}$$
 (k) k = qD  $_{1}V_{x}$  f<sub>0</sub> k: (5)

It can be seen that equations 2 and 5 have the same form, where the product of the DOS in the reservoirs and the transm ission probability in Eq. 2 plays the same role in determ ining the energy spectrum of electrons which carry current as the local DOS does in Eq. 5. This simple result provides an additional underpinning for U rich, B arnes and V ining's observation in [5] that therm ionic and therm oelectric devices refrigerate (or generate power) via the same e underlying physical mechanism. To show that there is no sharp transition in the behavior of a solid-state power generator or refrigerator as its width changes from L < to L > , one can use the fact that the probability that an electron can travel a distance L without su ering a collision is [11]

$$P = \exp(L = ) \tag{6}$$

to obtain an equation for energy-resolved current density useful in solid-state power generators and refrigerators of length L as

$$j(k) k = qv_x f_0 - D_1[1 P] + D_r P k.$$
 (7)

which can easily be generalized to the case where ! (k).

Equality between equations 2 and 5 results in a common expression for the electronic e ciency [12] (in therm ionic devices) and intensive e ciency [13, 14] (across a sm all section of therm oelectric m aterial) of

$$_{PG}^{b} = V J = Q_{H}$$
(8)

for a solid-state power generator and

$${}^{\rm b}_{\rm R} = Q_{\rm C} = V J \tag{9}$$

for a solid-state refrigerator, where the heat ux density in the cold/hot reservoir of a them ionic device, or at the cold/hot ends of the small section of therm celectric is given by ZZZ

$$Q_{C=H} = E(k) = E(k) = \frac{j(k)}{q} dk$$
 (10)

where the -/+ refers to the cold/hot case, and it is assumed that the temperature gradient, electric eld (" = V=L), and current have no components in the y and z dimensions. It is important to point out that the Eq. 10 considers only heat carried by electrons. If phonon mediated heat leaks are also considered, then two extra terms should be added to Eq. 10, the rst being  $T_1=L$ , where \_1 is the thermal conductivity of the lattice, while the second accounts for Youle' heat released by electrons which di use between the hot and cold reservoirs, part of which is then carried by phonons to each end of the device. Shakouri et al. [15] have shown that in the lim it that L then heat exactly half of this heat, V J, is deposited in the hot and cold reservoirs, while if L this heat is entirely deposited in the reservoir recieving the net current of electrons.

Finally, it can be shown that the above results yield the same expression for them aterials parameter in them ionic and them coelectric refrigerators. A ssum ing a dispersion relation of  $E = -k^2 k^2 = 2m$ , and three-dimensional reservoirs so that  $D = 1 = (2)^3$ , Eq. 2 m ay be used to obtain the same therm ionic materials parameter as found in [5], expressed in terms of the mean-free-path as

$$T_{TI} = -\frac{4 \text{ m } \text{k}}{1 \text{ h}^3} (\text{k}T_{\text{C}})^2$$
(11)

where 1 is the therm al conductivity of the lattice. The therm coelectric materials parameter may be obtained from [5]

$$= -\frac{T}{1} \frac{k^2}{q^2} F_0 ()^{-1}$$
(12)

where is the electrical conductivity and F  $_n$  is a Ferm i integral, given by

$$F_{n}() = \frac{1}{(n+1)} \int_{0}^{Z_{1}} \frac{n}{\exp((-)+1)} d$$
(13)

where the reduced Ferm i energy is  $= (E^{0}) = kT_{c}$  and  $E^{0}$  is the height of the barrier in therm ionic devices (so that = 0 for  $E < E^{0}$ , = 1 for  $E > E^{0}$ ) or the conduction band edge in a piece of therm coelectric. U sing the sam e dispersion relation and density of states as for therm ionic devices we can write an equation for conductivity in therm coelectric materials as

$$\frac{qJ^{d}}{d = dx} = \frac{4 \text{ m } q^{2}}{h^{3}} \sum_{k=1}^{Z} E \frac{dE_{0} (E)}{dE} dE$$
(14)

$$= \frac{4 \text{ m} \text{ k}}{h^3} q^2 \text{T} F_0 ()$$
 (15)

where we have used the fact that  $df_0 = dx = (d = dx) (df_0 = d)$  for dT = dx = 0, that  $df_0 = d = dx$ 

df=dE , and have integrated by parts to obtain the nalline. It can be seen by substitution that this yields =  $_{TI}$  if  $T = T_c$ .

In [5] the therm ionic and therm oelectric m aterials param eters were expressed in terms of the m obility of electrons. In order to do this for the therm oelectric m aterials param eter, two di erent expressions for conductivity were equated:

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$$= q^2 v_x^2 D_1 \frac{df_0}{dE} dE$$
(16)

where  $= {}_{0}E^{1=2}$ , and

$$= nq = q \qquad D_{1}f_{0}dE \qquad (17)$$

$$= \frac{q^2}{m} D_1 E \frac{dE_0}{dE}.$$
 (18)

Given that  $v_x^2 / E$  and q = m, it can be seen that the two equations do not give the same result for conductivity as the relaxation time is assumed to be proportional to  $E^{1=2}$  in the rst and independent of energy in the second, and this di culty results in the factor of  $F_0 = F_{1=2}^{p-1}$  identieed in [5].

In sum m ary, it has been shown that solid-state therm ionic and therm oelectric devices with a width close to the mean-free-path of electrons share a common equation for electrical current density and electronic electronic electron, and that their in aterial parameters' for refrigeration are equal.

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